

ABSTRACT OF THE DISCLOSURE

In a device for extracting processing residues for a processing apparatus having a plurality of processing units preferably movable along a processing path, particularly for an engraving machine having a plurality of engraving supports, an admission opening of an extraction conduit is allocated to each processing unit. The device has a collecting main for the extraction. For this purpose, the collecting main is preferably designed as an extraction channel, and the end of each of the extraction conduits facing away from the processing unit comprises a mouthpiece that discharges into the extraction channel, namely preferably into an admission slot of the extraction channel, whereby it is movable along and in the admission slot.